CLAIM AMENDMENT

The Applicants cancel claims 1-6 and 35-63.

1.-6. (cancelled)

7.(previously amended) A metal embedded sensor comprising:

- <u>a.</u> a metal structure comprising:
 - i. a metal having a melting temperature above 660°C;
 - ii. <u>a coating metallic layer;</u>
 - iii. an embedding metallic layer on the coating metallic layer; and
- b. a sensor embedded inside the metal structure;

and

wherein said metal structure is in direct adhesive contact with said sensor.

- 8. (cancelled)
- 9. (previously amended) The metal embedded sensor of claim 7, wherein the embedding metallic layer is formed by laser deposition.
- 10. (previously amended) The metal embedded sensor of claim 7, wherein the coating metallic layer comprises a first metallic layer, and a second metallic layer on the first metallic layer.
- 11. (original) The metal embedded sensor of claim 10, wherein one or more of the first and the second metallic layers is formed by sputtering.
- 12. (*original*) The metal embedded sensor of claim 10, wherein one or more of the first and the second metallic layers is formed by electroplating.

- 13. (*original*) The metal embedded sensor of claim 10, wherein the first metallic layer is formed by sputtering, and the second metallic layer is formed by electroplating.
- 14. (*original*) The metal embedded sensor of claim 10, wherein the thickness of the first metallic layer is between about one and about three microns.
- 15. (original) The metal embedded sensor of claim 10, wherein the first metallic layer comprises a metal selected from the group consisting of copper, nickel, iron, and platinum.
- 16. (*original*) The metal embedded sensor of claim 10, wherein the thickness of the second metallic layer is between about one-quarter and about two millimeters.
- 17. (original) The metal embedded sensor of claim 10, wherein the second metallic layer comprises a metal selected from the group consisting of copper, nickel, iron, and platinum.
- 18. (original) The metal embedded sensor of claim 17, wherein the sensor is in the form of a fiber optic sensor.
- 19. (*original*) The metal embedded sensor of claim 18, further comprising an adhesive layer coating the sensor.
- 20. (original) The metal embedded sensor of claim 19, wherein the adhesive layer comprises titanium.

- 21. (*original*) The metal embedded sensor of claim 20, wherein the thickness of the adhesive layer is between about 2nm and about 3nm.
- 22. (previously amended) The metal embedded sensor of claim 7, wherein the sensor is in the form of a thin film thermo-mechanical sensor, and wherein the metal structure comprises:
 - a. a coating metallic layer comprising
 - i. a first metallic layer;
 - ii. a second metallic layer on the first metallic layer, said second metallic layer selected from the group consisting of copper, nickel, iron, and platinum; and
 - b. an embedding metallic layer on the coating metallic layer.
- 23. (previously amended) The metal embedded sensor of claim 22, wherein the sensor comprises:
 - a. a first insulating layer;
 - b. a sensor layer disposed on the first insulating layer;
 - c. a second insulating layer disposed on the sensor layer; and wherein said first insulating layer and said second insulating layers are deposited of an insulating material with a maximum thickness for providing adequate electric insulation of said sensor layer in operation.
- 24. (*original*) The metal embedded sensor of claim 23, wherein the sensor further comprises an adhesive layer contacting the first insulating layer.
- 25. (*original*) The metal embedded sensor of claim 24, wherein the adhesive layer comprises titanium.
- 26. (*original*) The metal embedded sensor of claim 25, wherein the thickness of the adhesive layer is between about 2nm and about 3nm.

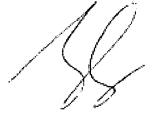
- 27. (*original*) The metal embedded sensor of claim 26, wherein the sensor further comprises a substrate contacting the adhesive layer.
- 28. (*original*) The metal embedded sensor of claim 27, wherein the substrate comprises a metallic substrate.
- 29. (original) The metal embedded sensor of claim 28, wherein the substrate comprises stainless steel.
- 30. (original) The metal embedded sensor of claim 23, wherein the sensor layer comprises constantan.
- 31. (*original*) The metal embedded sensor of claim 23, wherein the thickness of the first insulating layer is between about 10nm and about 15nm.
- 32. (*original*) The metal embedded sensor of claim 23, wherein the thickness of the second insulating layer is between about 10nm and about 15nm.
- 33. (*original*) The metal embedded sensor of claim 23, wherein the first and the second insulating layers comprise insulating oxides.
- 34. (*original*) The metal embedded sensor of claim 33, wherein the first and the second insulating layers comprise alumina.

35. – 63. (*cancelled*)

IN CONCLUSION

The Applicants have cancelled the withdrawn claims and respectfully request the application being reconsidered and allowed in the next Office Action.

Respectfully submitted,



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